



IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**Applicant:** Keiichiro KATA & Shinichi CHIKAKI

**Title:** PROCESS FOR MANUFACTURING SEMICONDUCTOR DEVICE AND SEMICONDUCTOR WAFER

**Serial No.:** 10/645,782

**Filed:** August 22, 2003

**Examiner:** Mark Prenty

**Art Unit:** 2822

**AMENDMENT AND REPLY UNDER 37 C.F.R. 1.173**

**Box AF**

Commissioner of Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

This amendment and reply is being filed in response to an Office Action dated November 17, 2005.

**Amendments to the Claims** begin on page 2 of this document.

**Remarks/Arguments** begin on page 4 of this document.

Please amend the application as follows: